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PATENT

IN THE UNITED STATES DESIGNATED OFFICE (DO/US)

PCT/US2004/023869
INTERNATIONAL APPLICATION NO.

26 July 2004 (26.07.2004)
INTERNATIONAL FILING DATE

25 July 2003 (25.07.2003)
PRIORITY DATE CLAIMED

TITLE OF INVENTION

SEMICONDUCTOR ELEMENTS HAVING ZONES OF REDUCED OXYGEN

APPLICANT(S) FOR DO/US

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Attention: DO/US
Commissioner for Patents
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Janet M. Stevens
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PRELIMINARY AMENDMENT

Sir:

Prior to examination, please amend the subject application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.